



AF/1763/

520.36911VX1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Applicant(s): T. ONO, et al
Serial No.: 09/691,119
Filed: October 19, 2000
For: METHOD AND APPARATUS FOR TREATING SURFACE OF SEMICONDUCTOR
Group: 1763
Examiner: A. Olsen

PETITION FOR EXTENSION OF TIME

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

January 30, 2004

Sir:

In the matter of the above-identified application, applicant(s) hereby respectfully petition for an extension of time to permit filing of a response within the first month subsequent to the shortened statutory period set in the outstanding Office Action mailed September 30, 2003. A payment in the amount of \$110.00 to cover the required fee for the requested extension of time is attached hereto.

It is respectfully requested that any shortage in the fee be charged to the account of Antonelli, Terry, Stout & Kraus, LLP, Account No. 01-2135 (520.36911VX1).

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Respectfully submitted,

Melvin Kraus

Registration No. 22,466

ANTONELLI, TERRY, STOUT & KRAUS, LLP

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